Amendments to the Drawings:

The attached sheet of drawings includes changes to Figure 3. As described in detail below, Figure 3 has been amended to correct the reference for auxiliary substrate 3 and to correct the reference for the ITO pattern described in the present specification at page 5, line 20. This sheet, which includes Figures 1 and 3, replaces the original sheet including Figures 1 and 3.

Attachment: Replacement Sheet

REMARKS

The Official Action mailed August 18, 2004, has been received and its contents carefully noted. This response is filed within three months of the mailing date of the Official Action and therefore is believed to be timely without extension of time. Also, filed concurrently herewith is a *Request for Continued Examination*. Accordingly, the Applicants respectfully submit that this response is being timely filed.

The Applicant notes with appreciation the consideration of the Information Disclosure Statements filed on November 19, 2001, March 12, 2002, March 3, 2003, the first IDS of April 28, 2003 (received by OIPE on April 30, 2003), and May 29, 2003.

However, despite two previous requests, the Applicant still has not received clear and unambiguous acknowledgment of the Information Disclosure Statements timely filed on December 23, 2002, and the second IDS of April 28, 2003 (received by OIPE on May 2, 2003). As noted in a *Supplemental Response* filed May 17, 2004, and again noted in a *Request for Acknowledgment of Information Disclosure Statement* filed September 20, 2004, regarding the IDS filed December 23, 2002, the Examiner is thanked for indicating his consideration of the three documents cited under "OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS" by adding his initials next to each citation. However, the record now shows that the citations are both crossed through and initialed by the Examiner. In order to clarify the record, the Applicant has provided a clean copy of the IDS filed December 23, 2002, so that the record may clearly show the Examiner's consideration of the references cited therein, and so that the documents cited therein are properly recorded on the face of the patent upon issuance.

Regarding the second IDS filed April 28, 2003 (received by OIPE on May 2, 2003), which cites JP 63-316885 and FR 2549627, the Examiner is thanked for indicating his consideration of JP '885 and FR '627 by citing these references on a Form PTO-892. However, it is not clear from the record whether the full translations of these documents as submitted have been considered by the Examiner. In order to clarify the

record, the Applicant has provided a clean copy of the second IDS of April 28, 2003 (received by OIPE on May 2, 2003), so that the record may clearly show the Examiner's consideration of the full translations of JP '885 and FR '627.

The Applicants respectfully request that the Examiner provide an initialed copy of the attached Form PTO-1449 evidencing consideration of these IDSs.

Claims 35 and 38-60 are pending in the present application. The Applicants note with appreciation the allowance of all the claims (Paper No. 20040809).

Figure 3 and page 5 of the specification have been amended to correct minor typographical errors and to be consistent with the written description. No new matter has been added. Specifically, Figure 3 has been amended to correct the reference for auxiliary substrate 3. The specification clearly supports a first substrate 1 and auxiliary substrate 3, i.e. the specification, in the paragraph bridging pages 5 and 6, notes the following:

> The electric connection between the first and second substrates 1 and 2 and the counterpart auxiliary substrates 3 respectively are done as follows. The extended inside surfaces of the first substrates 1 on which terminals of the respective electrodes are exposed are coated, by means of a dispenser, with an anisotropic conductive film. The adhesive film is made from a UV light curable adhesive 8 in which a number of resilient fine conductive particles 6 and hard particles 7 whose diameter is slightly smaller than that of the resilient particles are dispersed.

Also, at page 6, lines 12-16, describes the following:

> Then, the first substrate 1 and the auxiliary substrates 3 are joined with the adhesive therebetween in order that the terminals of the first substrate 1 and the corresponding contacts of the auxiliary substrate 3 are aligned to each other, and exposed to UV light for 3 minutes under pressure of about 2.4 kg/cm^2.

Thus, in accordance with the present invention as described in the specification, substrate 1 is joined with auxiliary substrate 3, and substrate 2 is joined to substrate 3' using adhesive 8.

Figure 3 is amended by replacing "2" with "3" so that Figure 3 accurately shows the first substrate 1 and the auxiliary substrates 3 joined with the adhesive therebetween, as described in the written specification.

Furthermore, in preparing the U.S. specification, a reference "19" to an ITO pattern was inadvertently omitted. Due to a typographical oversight, the ITO pattern in Figure 3 was designated "9" instead of "19." Figure 3 and page 5 of the specification have also been amended to correct the reference for the ITO pattern described in the present specification at page 5, line 20. Specifically, at page 5, line 20, an ITO pattern formed on the substrate 3 is described but no reference number is provided.

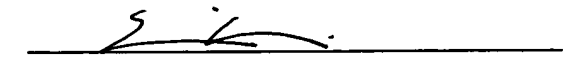
Still further, the Applicant respectfully submits that the ITO pattern corresponds with wiring 19 as described at page 12, lines 13-15, of a verified English translation of Japanese Priority Document No. 1-232308, which was submitted during the prosecution history of parent application Serial No. 08/962,448, filed October 31, 1997, now U.S. Patent No. 6,404,476. It is also noted that Figure 2 of JP '308, which corresponds with Figure 3 of the present application, clearly designates the auxiliary substrate with reference "3" and the ITO pattern with reference "19."

Therefore, the Applicant has amended Figure 3 in the present application by replacing "9" at the top of the Figure with "19," and the Applicant has amended the paragraph beginning at page 5, line 17, to recite that the "auxiliary substrates 3 are provided by depositing ITO films on 1.1 mm thick sodalime glass substrates .... The ITO film is patterned by a known photolithography. The ITO pattern 19 is then coated with Ni and thereafter with Au respectively by plating."

No new matter is added by these corrections. The specification clearly discloses that first substrate 1 and auxiliary substrates 3 are joined with adhesive 8 therebetween. The amendments merely conform Figure 3 with the written description and are appropriate to maintain consistency between the Figures and the written description.

Should the Examiner believe that anything further would be desirable to place this application in better condition for allowance, the Examiner is invited to contact the undersigned at the telephone number listed below.

Respectfully submitted,



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